

Notice of References Cited	Application/Control No. 09/992,624	Applicant(s)/Patent Under Reexamination HIEW ET AL.	
	Examiner Fred Ferris	Art Unit 2128	Page 1 of 1

U.S. PATENT DOCUMENTS

*	Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A US-			
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FOREIGN PATENT DOCUMENTS

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NON-PATENT DOCUMENTS

*	Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)	
U	"An Analysis of Geometric Modeling in Database Systems", Kemper et al, ACM Computing Surveys, Vol. 19, No. 1, March 1987	
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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